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Docket No. 0008-FA-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Hunt et al.

Application No. 09/748,714 (Conf. No. 4539)

Filed: 21 December 2000

For: CHEMICAL VAPOR DEPOSITION METHODS FOR MAKING
POWDERS AND COATINGS, AND COATINGS MADE
USING THESE METHODS

Information Disclosure Statement

Assistant Secretary and Commissioner of Patents and Trademarks
Washington D.C. 20231

As an Information Disclosure Statement, Applicants are submitting herewith a copy of the International Search Report on PCT/US00/35416 identical to the instant U.S.

27 April, 2001

Wayne E. Nacker

Wayne E. Nacker, Reg. 29,571

Customer No. 24948

I, Wayne E. Nacker, certify that this document, and the documents discussed herein are being deposited with the U.S. Postal Service, First Class Mail, postage prepaid, on 27 April 2001.

Wayne E. Nacker

/David Turocy/

01/22/2007